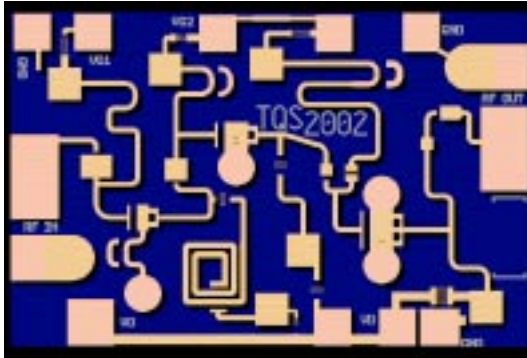


K Band Low Noise Amplifier

TGA4506

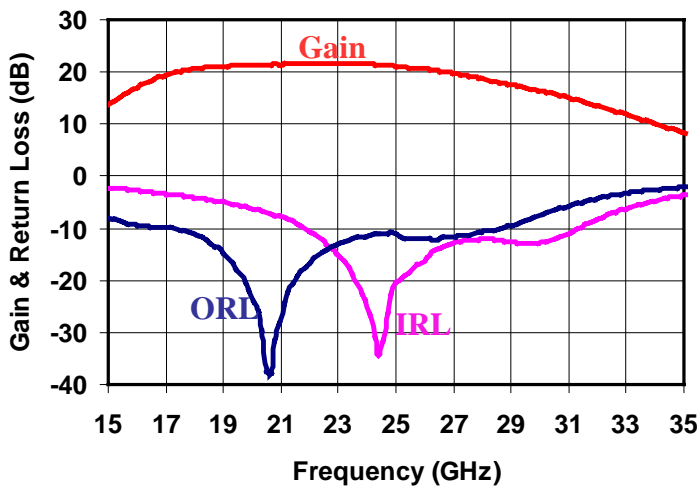


Key Features

- Typical Frequency Range: 20 - 27 GHz
- 21 dB Nominal Gain
- 2.2 dB Nominal Noise Figure
- 12 dBm Nominal P1dB
- Bias 3.5 V, 60 mA
- 0.15 um 3MI pHEMT Technology
- Chip Dimensions 1.2 x 0.8 x 0.1 mm (0.047 x 0.031 x 0.004) in

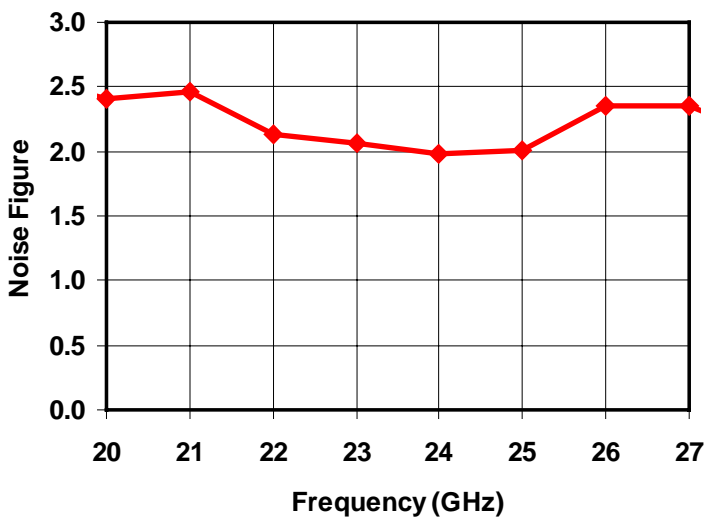
Preliminary Measured Data

Bias Conditions: $V_d = 3.5\text{ V}$, $I_d = 60\text{ mA}$



Primary Applications

- Point-to-Point Radio
- Point-to-MultiPoint Radio
- LMDS



Note: Devices designated as EPU are typically early in their characterization process prior to finalizing all electrical and process specifications. Specifications are subject to change without notice

TABLE I
MAXIMUM RATINGS 1/

SYMBOL	PARAMETER	VALUE	NOTES
V _d	Drain Voltage	5 V	<u>2/</u>
V _g	Gate Voltage Range	-1 TO +0.5 V	
I _d	Drain Current	190 mA	<u>2/ 3/</u>
I _g	Gate Current	6 mA	<u>3/</u>
P _{IN}	Input Continuous Wave Power	TBD	
P _D	Power Dissipation	TBD	<u>2/ 4/</u>
T _{CH}	Operating Channel Temperature	150 °C	<u>5/ 6/</u>
T _M	Mounting Temperature (30 Seconds)	320 °C	
T _{STG}	Storage Temperature	-65 to 150 °C	

- 1/ These ratings represent the maximum operable values for this device.
- 2/ Combinations of supply voltage, supply current, input power, and output power shall not exceed P_D.
- 3/ Total current for the entire MMIC.
- 4/ When operated at this bias condition with a base plate temperature of TBD, the median life is reduced from TBD to TBD hrs.
- 5/ Junction operating temperature will directly affect the device median time to failure (MTTF). For maximum life, it is recommended that junction temperatures be maintained at the lowest possible levels.
- 6/ These ratings apply to each individual FET.

TABLE II
DC PROBE TESTS
(Ta = 25 °C Nominal)

SYMBOL	PARAMETER	MINIMUM	MAXIMUM	VALUE
V _{P3}	Pinch-off Voltage	-1.0	-0.1	V

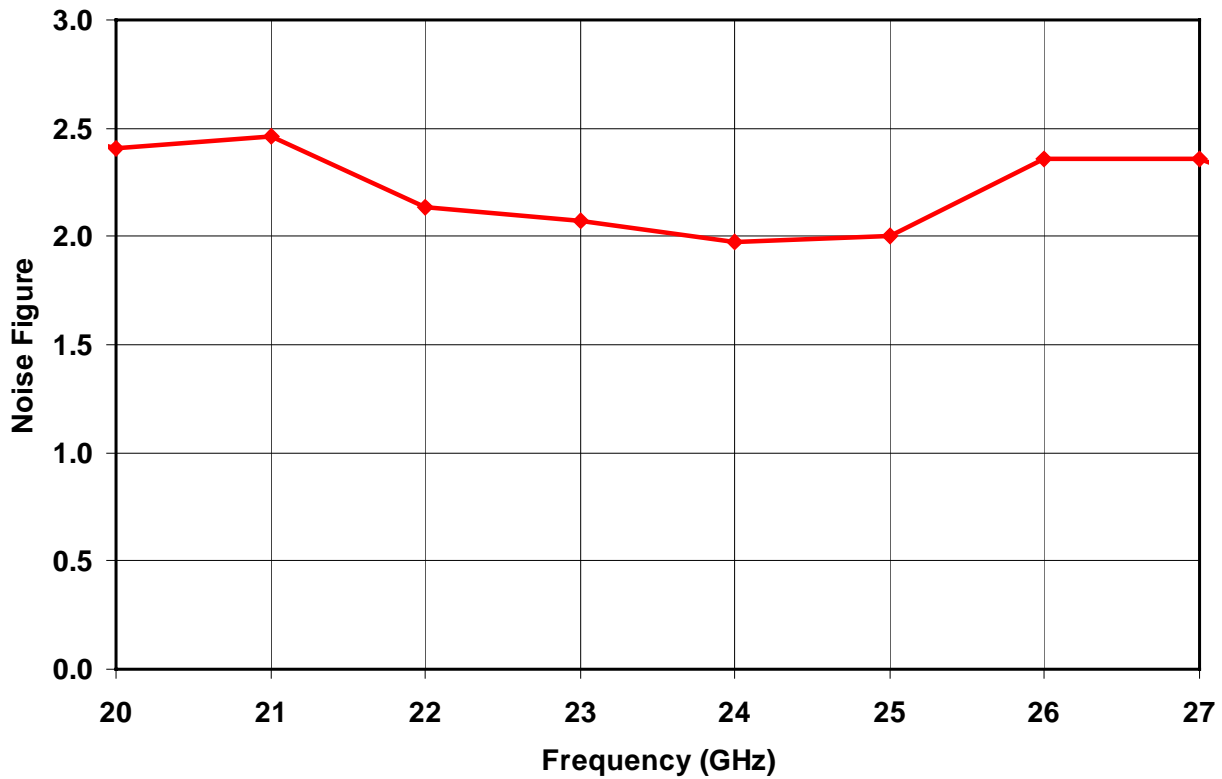
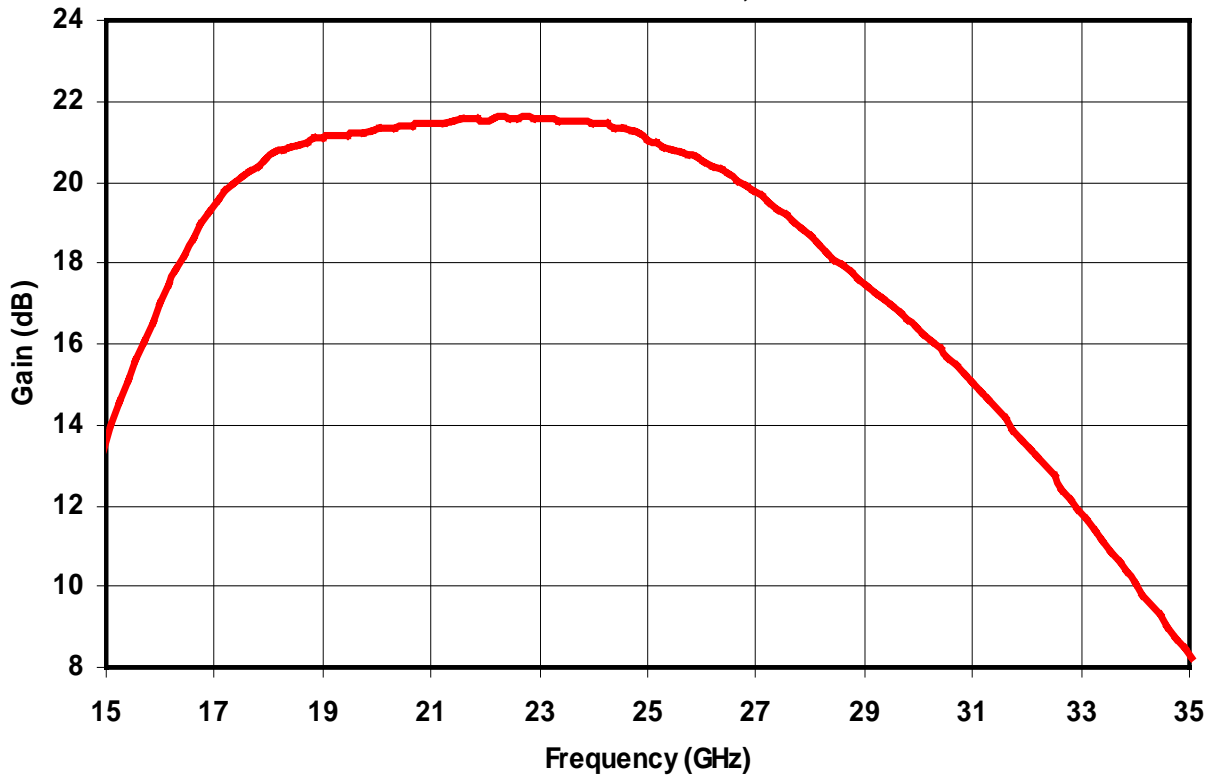
Q3 is 300 um FET

TABLE III
ELECTRICAL CHARACTERISTICS
(Ta = 25 °C Nominal)

PARAMETER	TYPICAL	UNITS
Drain Voltage, Vd	3.5	V
Drain Current, Id	60	mA
Gate Voltage, Vg	-0.5 to 0	V
Small Signal Gain, S21	21	dB
Input Return Loss, S11	15	dB
Output Return Loss, S22	11	dB
Noise Figure, NF	2.2	dB
Output Power @ 1 dB Compression Gain, P1dB	12	dBm

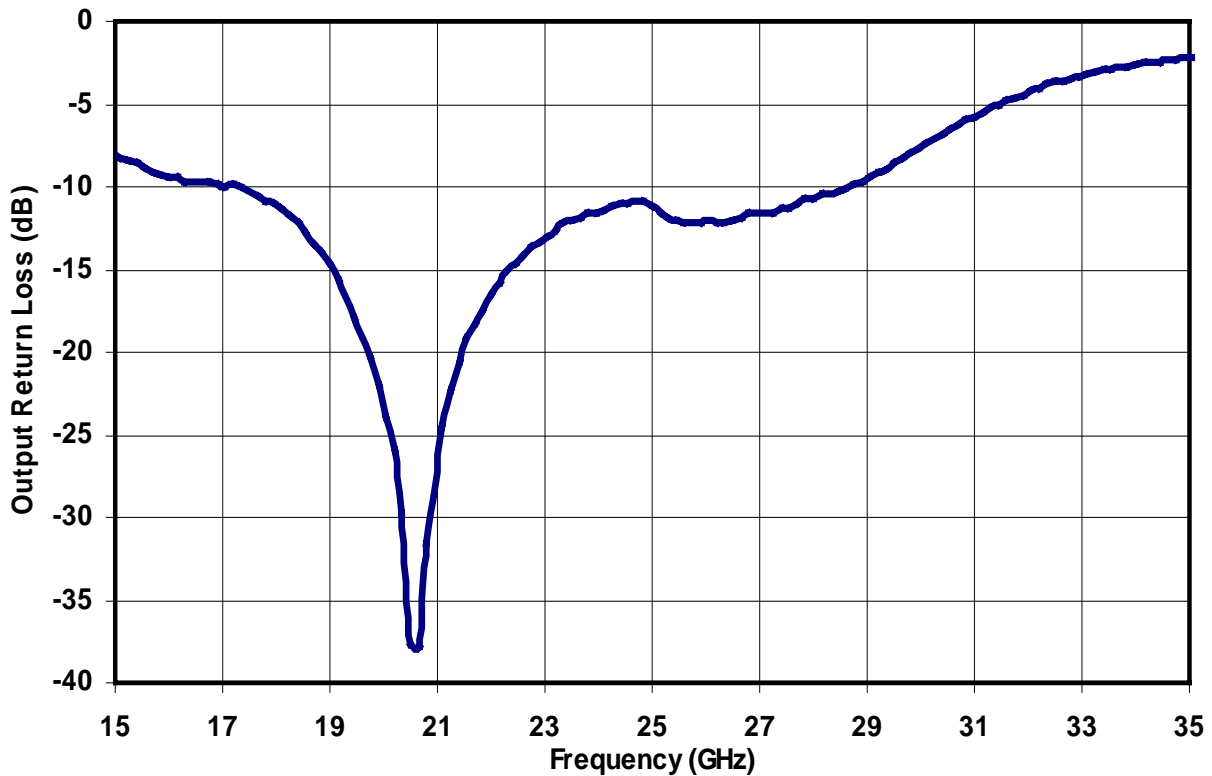
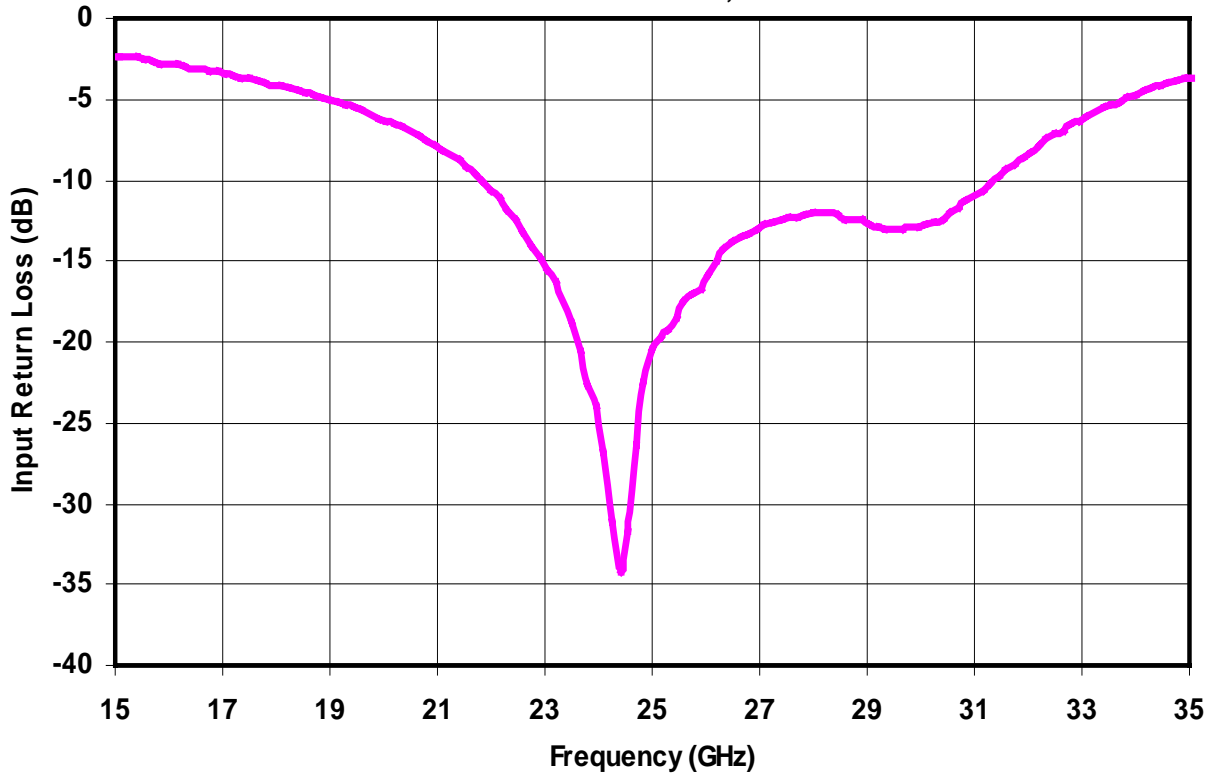
Measured Data

Bias Conditions: $V_d = 3.5\text{ V}$, $I_d = 60\text{ mA}$



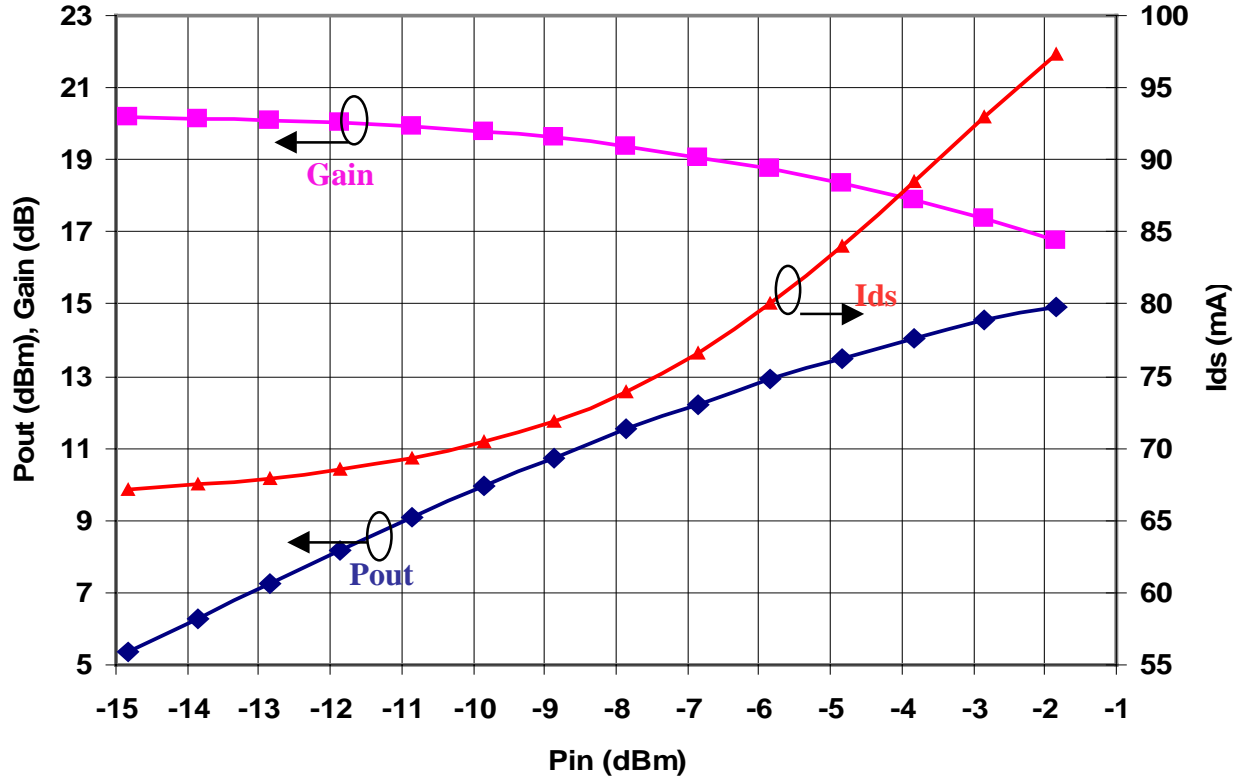
Measured Data

Bias Conditions: $V_d = 3.5\text{ V}$, $I_d = 60\text{ mA}$

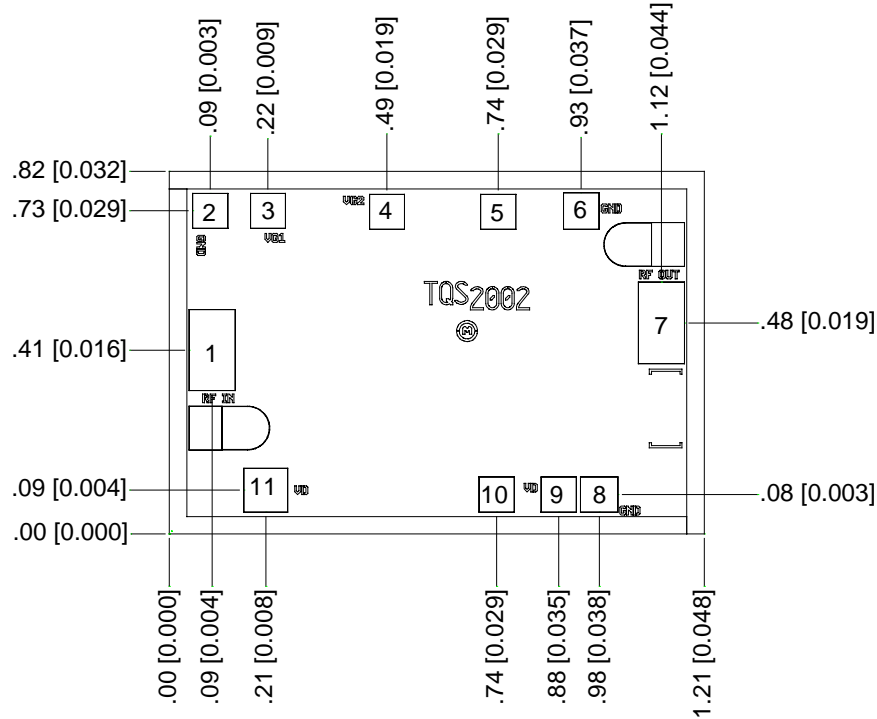


Measured Data

Bias Conditions: $V_d = 3.5\text{ V}$, $I_d = 60\text{ mA}$, Freq @ 24 GHz



Mechanical Drawing



Units: millimeters [inches]

Thickness: 0.10 [0.004] (reference only)

Chip edge to bond pad dimensions are shown to center of bond pads.

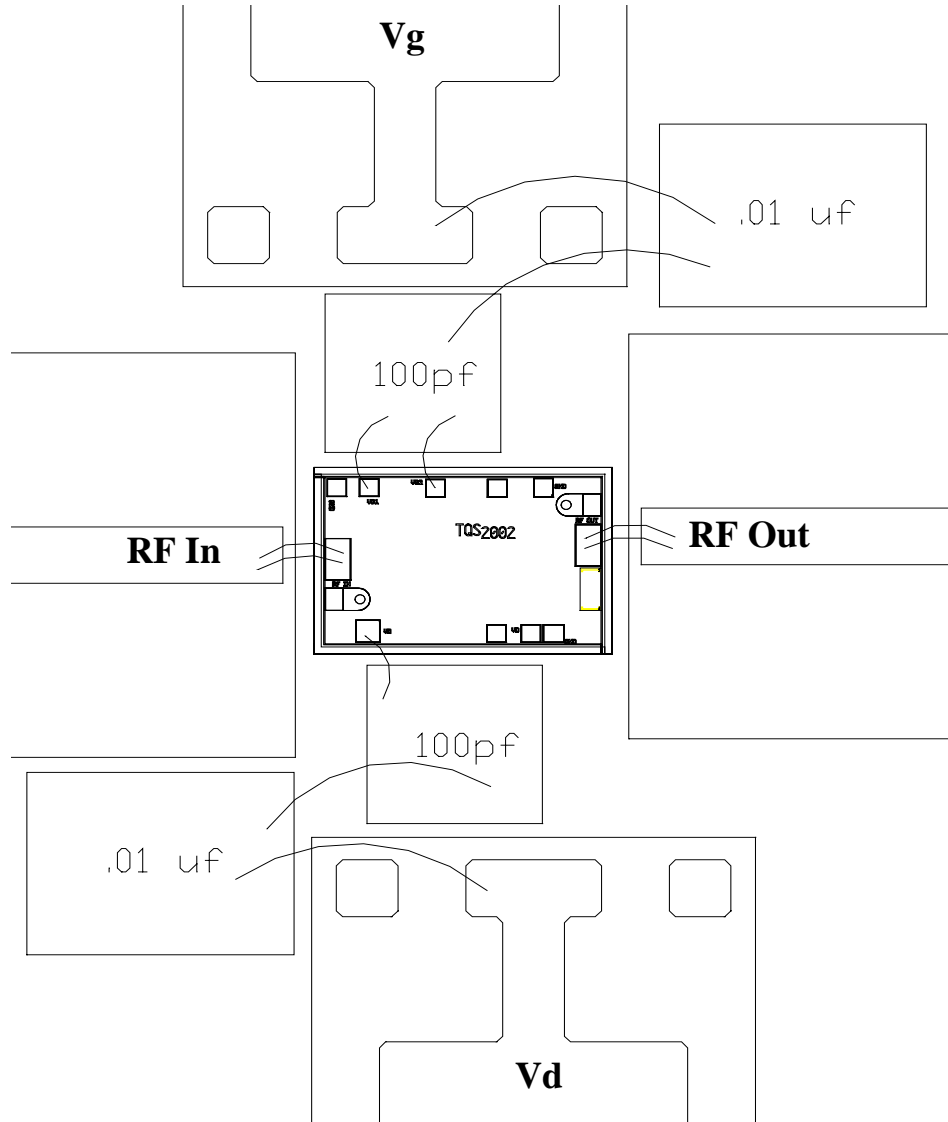
Chip size tolerance: ±0.05 [0.002]

RF ground through backside

Bond Pad #1	RF Input	0.11 x 0.19	[0.004 x 0.007]
Bond Pad #2	N/C	0.08 x 0.08	[0.003 x 0.003]
Bond Pad #3	VG1	0.08 x 0.08	[0.003 x 0.003]
Bond Pad #4	VG2	0.08 x 0.08	[0.003 x 0.003]
Bond Pad #5	N/C	0.08 x 0.08	[0.003 x 0.003]
Bond Pad #6	N/C	0.08 x 0.08	[0.003 x 0.003]
Bond Pad #7	RF Output	0.11 x 0.19	[0.004 x 0.007]
Bond Pad #8	N/C	0.09 x 0.08	[0.004 x 0.003]
Bond Pad #9	VD	0.09 x 0.08	[0.004 x 0.003]
Bond Pad #10	VD	0.09 x 0.08	[0.004 x 0.003]
Bond Pad #11	VD	0.10 x 0.10	[0.004 x 0.004]

GaAs MMIC devices are susceptible to damage from Electrostatic Discharge. Proper precautions should be observed during handling, assembly and test.

Chip Assembly Diagram



**All three Vd pads (pad # 9, 10, 11 from mechanical drawing)
do not need to be connected**

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Assembly Process Notes

Reflow process assembly notes:

- Use AuSn (80/20) solder with limited exposure to temperatures at or above 300°C (30 seconds max).
- An alloy station or conveyor furnace with reducing atmosphere should be used.
- No fluxes should be utilized.
- Coefficient of thermal expansion matching is critical for long-term reliability.
- Devices must be stored in a dry nitrogen atmosphere.

Component placement and adhesive attachment assembly notes:

- Vacuum pencils and/or vacuum collets are the preferred method of pick up.
- Air bridges must be avoided during placement.
- The force impact is critical during auto placement.
- Organic attachment can be used in low-power applications.
- Curing should be done in a convection oven; proper exhaust is a safety concern.
- Microwave or radiant curing should not be used because of differential heating.
- Coefficient of thermal expansion matching is critical.

Interconnect process assembly notes:

- Thermosonic ball bonding is the preferred interconnect technique.
- Force, time, and ultrasonics are critical parameters.
- Aluminum wire should not be used.
- Maximum stage temperature is 200°C.

GaAs MMIC devices are susceptible to damage from Electrostatic Discharge. Proper precautions should be observed during handling, assembly and test.